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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6548**
Sunji ICHIKAWA : Docket No. 2004-0095A
Serial No. 10/763,227 : Group Art Unit 2822
Filed January 26, 2004 : Examiner Roy Karl Potter

LEAD FRAME, MANUFACTURING METHOD
OF THE SAME, AND SEMICONDUCTOR
DEVICE USING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the restriction requirement on page 2 of the Office Action dated April 25, 2005, the Applicant hereby elects **Invention II**, which is drawn to a semiconductor device. Claims 3-4 read on the elected invention.

Having made the required election, a full examination on the merits is respectfully requested.

Respectfully submitted,

Sunji ICHIKAWA

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